

277EAST - [id: 11] [wsp: 1]

File Edit View Settings Tools Window Help

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near2 surface
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S1: (227814) measur\$ with surface
S2: (80127) measur\$ near2 surface
S3: (80127) S1 and S2
S4: (5916) S3 and conjugat\$
S5: (326) S4 and ((aperture or stop) with conjugat\$)
S6: (127) S5 and (adjust\$ with (aperture or stop))
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Search [US:PGPUB:USPAT] Common [P] [Push] [H] [Highlight all hit terms exactly]

Details pane: OR [P] [Push] [H] [Highlight all hit terms exactly]

S and (adjust\$ with (aperture or stop))

BR\$ form ISIR form Image Text HTML

	U	A1	Document ID	Issue Date	Pages	Title	Current OR	Current XRef	Retrieval C	Inventor	S	C	P	U	Im
1	<input type="checkbox"/>	<input type="checkbox"/>	US 20050128452 A1	20050616	67	Wavelength selecting method, position detecting method	355/55	355/67		Matsumoto, Takahiro	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
2	<input type="checkbox"/>	<input type="checkbox"/>	US 20050051742 A1	20050310		Method of detecting position of mark on substrate,	250/548			Shiraishi, Naomasa	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
3	<input type="checkbox"/>	<input type="checkbox"/>	US 20050024610 A1	20050203		Exposure apparatus and stage device, and device	355/53	355/55		Nishi, Kenji et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
4	<input type="checkbox"/>	<input type="checkbox"/>	US 20040218158 A1	20041104		Exposure method and device	355/30	355/53; 355/55		Nishi, Kenji	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
5	<input type="checkbox"/>	<input type="checkbox"/>	US 20040159787 A1	20040819		Electron beam system	250/311			Nakasuji, Mamoru et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
6	<input type="checkbox"/>	<input type="checkbox"/>	US 20040105085 A1	20040603		Image formation characteristics adjustment	355/69	250/548; 355/53;		Suzuki, Kousuke	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
7	<input type="checkbox"/>	<input type="checkbox"/>	US 20040102043 A1	20040527		Confocal 3D inspection system and process	438/689			Watkins, Cory et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
8	<input type="checkbox"/>	<input type="checkbox"/>	US 20040080736 A1	20040429		Imaging method for manufacture of microdevices	355/53			Suzuki, Akiyoshi et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
9	<input type="checkbox"/>	<input type="checkbox"/>	US 20040059321 A1	20040325		Automated laser workstation for high precision surgical	606/10	606/3; 606/5		Knopp, Carl K. et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
10	<input type="checkbox"/>	<input type="checkbox"/>	US 20040051847 A1	20040318		Device and method for imaging, stimulation,	351/200	351/159; 351/246		Vilser, Walthard	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
11	<input type="checkbox"/>	<input type="checkbox"/>	US 20040042648 A1	20040304		Image processing method and unit, detecting method and	382/151			Yoshida, Kouji et al.	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>

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